

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

| | | |
|--------------------------------|---|----------------------------------|
| Applicants : CHEN ET AL. |) | Confirmation No. 8561 |
| |) | |
| Serial No. : 10/733,721 |) | Examiner: Evan Pert |
| |) | Group Art Unit: 2826 |
| Filed : 11 December 2003. |) | TKHR Ref. 250914-1010 |
| For : Method of Forming Poly- |) | Tsai, Lee & Chen Ref. NP-1812-US |
| Silicone Thin Film Transistors |) | |
| |) | |

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action February 10, 2006 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.